

17th

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Bayan et al.

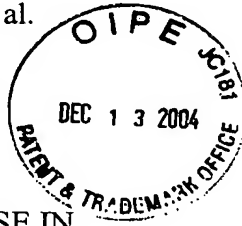
Attorney Docket No.: NSC1P274/P05649

Application No.: 10/650,325

Examiner: Im, J.

Filed: August 27, 2003

Group: 2811

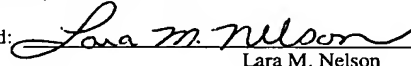


Title: SUBSTRATE FOR USE IN  
SEMICONDUCTOR MANUFACTURING AND  
METHOD OF MAKING SAME

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on December 8, 2004 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed:

  
Lara M. Nelson

**AMENDMENT TRANSMITTAL**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:


Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	26	MINUS	30	00	x 25 =	x 50 =
Independent Claims	03	MINUS	04	00	x 100 =	x 200 =
Multiple Dependent Claim Present and Fee Not Previously Paid					\$180.00	\$360.00
Total					\$	\$

- ☐ Applicant(s) hereby petition for a \_\_\_\_\_ month extension(s) of time to respond to the aforementioned Office Action.
- ☒ Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 500388.
- ☐ Enclosed is our Check No. \_\_\_\_\_ in the amount of \$\_\_\_\_\_ to cover the additional claim fee and/or extension of time fees.
- ☒ Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 500388 (Order No. NSC1P274).

Respectfully submitted,  
BEYER WEAVER & THOMAS, LLP

  
Steve D Beyer  
Reg. No. 31,234

P.O. Box 778  
Berkeley, CA 94704-0778

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Signed: \_\_\_\_\_

*Lara M. Nelson*  
Lara M. Nelson

**AMENDMENT A**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated November 17<sup>th</sup>, 2004 please amend the above-identified patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which being on page 2 of this papers.

**Remarks/Arguments** begin on page 7 of this paper.